



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Group Art Unit: 2812
Examiner: Not yet assigned
Confirmation No.: 4501

In re PATENT APPLICATION of:

Applicant(s): Osamu KATO

Serial No.: 10/689,032

Filed: October 21, 2003

For: METHOD FOR FABRICATING A GATE
MASK OF A SEMICONDUCTOR DEVICE

Docket No.: FUJI 138

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)
)
)
) **SUBMISSION OF**
) **FORMAL DRAWINGS**
)
)
)

April 13, 2004

MAIL STOP PGPUB DRAWINGS

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

Applicant hereby submits seven (7) replacement sheets of Formal Drawings
(Figs. 1A-5).

Respectfully submitted,

Robert H. Berdo, Jr.
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April 13, 2004
Date

RHB:crh

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